

Electronic Patent Application Fee Transmittal

Application Number:	10805966			
Filing Date:	22-Mar-2004			
Title of Invention:	Plasma immersion ion implantation apparatus and method			
First Named Inventor/Applicant Name:	Vikram Singh			
Filer:	Changhoon Choi/Constance S. Ouellette			
Attorney Docket Number:	2003-42/43			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 3 months with \$0 paid	1253	1	1110	1110

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				1110